

Notice of References Cited	Application/Control No. 10/656,944	Applicant(s)/Patent Under Reexamination KWON ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,454,763 A	10-1995	Ikebuchi et al.	475/128
	B	US-5,882,276 A	03-1999	Usuki et al.	477/120
	C	US-2003/0027679 A1	02-2003	Sakamoto et al.	475/120
	D	US-5,168,776 A	12-1992	Otsubo et al.	477/109
	E	US-5,853,349 A	12-1998	Shimada et al.	477/143
	F	US-6,723,022 B2	04-2004	Kim, Gi-Joon	477/70
	G	US-5,809,442 A	09-1998	Schulz et al.	701/51
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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